Att. Docket No. 10191/1690 NITED STATES PATENT AND TRADEMARK OFFICE

Appl. Serial No.

09/762,985

Confirmation No. 2674

Title

DEVICE AND METHOD FOR

ETCHING A SUBSTRATE USING

AN INDUCTIVELY COUPLED PLASMA

Applicant(s)

Volker BECKER et al.

Filed

May 8, 2001

TC/A.U.

1763

Examiner

Luz L Alejandro Mulero

Docket No.

10191/1690
I hereby certify that this correspondence is being deposited with the

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**AMENDMENT** 

AARON C (33,865)

SIR:

In response to the Office Action mailed on February 23, 2005 (the three-month response date for which has been extended by three months from May 23, 2005 to August 23, 2005 by the accompanying Transmittal and Petition to Extend), please reconsider the above-identified application based on the following:

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

08/15/2005 MBERHE

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